

Electronic Patent Application Fee Transmittal

Application Number:	10552262			
Filing Date:	05-Oct-2005			
Title of Invention:	METHOD FOR REMOVING SILICON OXIDE FILM AND PROCESSING APPARATUS			
First Named Inventor/Applicant Name:	Kazuhide Hasebe			
Filer:	Michael A. Makuch/Cynthia Johnson			
Attorney Docket Number:	33082M275			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1510	1510
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Printed copy of patent - no color	8001	2	3	6
Total in USD (\$)				1816